

Special Issue

Micro-Optics Devices

Message from the Guest Editor

Due to the remarkable advances of micro-optics devices in design, manufacturing process, and material, the performance of micro-optical-related devices has achieved significant improvement. These micro-optical devices have recently attracted a great deal of attention and played crucial roles in a variety of fields, such as in energy, sensors, green engineering, displays, 3C consumer electronics, semiconductor, biomedical applications, etc. The scope of this Special Issue, “Micro-Optics Devices”, can cover the various aspects of the design, manufacture, and application of micro-optics or optical-related sensing device studies, as well as their latest development. We sincerely invite you to contribute your original papers to this Special Issue. The topics of interest include but are not limited to:

- Optical fiber sensors;
- Optical thin film devices;
- Modeling and design of micro-optics lenses;
- Optical-related and micro-optical sensors;
- Nanostructured micro-optical devices;
- Novel optical fiber sensors and their applications;
- Manufacture of micro-optics devices.

Guest Editor

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Deadline for manuscript submissions

closed (25 May 2023)



Micromachines

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Impact Factor 3.0
CiteScore 6.0
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Message from the Editor-in-Chief

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